

Electronic Acknowledgement Receipt

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International Application Number:	
Confirmation Number:	3280
Title of Invention:	Positive-type resist composition for liquid immersion lithography and method for forming resist pattern
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed (SB/08)	1608-7_PCT-US_IDS_3-19-09. pdf	871143 <small>18740d28c6b2a48e7afebe56a664bcb514306da</small>	no	4

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2	Foreign Reference	EP1319981.pdf	3193477 e49c73bafdb6cc5ea4c4173a428add89685d0678	no	80
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3	Foreign Reference	EP1505439.pdf	2060009 380bac3889244a7a885d6d106bc1dd97eba89423	no	63
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4	NPL Documents	Sato_article.pdf	1089917 67c8e4dd70acc18261047487f7facdaf14a71578	no	20
Warnings:					
Information:					
5	NPL Documents	Taylor_article.pdf	480409 0fb9e5be5139b4bbfc3a6e02902cec8ae54b2b9e	no	10
Warnings:					
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6	NPL Documents	Hinsberg_article.pdf	871361 20431c7f0548df9d684d2e2fc9fccbefb052680e	no	13
Warnings:					
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7	NPL Documents	Supplementary_SR.pdf	186567 deaa321056b7a5e55442c843ddc7b1a0c0704aec	no	5
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National Stage of an International Application under 35 U.S.C. 371

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